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Atty Docket 0756-1936

Serial No. 09/255,777

## INFORMATION DISCLOSURE STATEMENT

APR 22 2002

Applicants: Shunpei YAMAZAKI et al.

Filing Date: February 23, 1999

Group Art Unit: 2812

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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	02-153896	06/13/1990	JP			Eng Abst
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(Including Author, Title, Date, Pertinent Pages, Etc.)

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HS	Hanada et al., "Preparation and Physical Properties of rf-Sputtered Amorphous Films in the Al <sub>x</sub> O <sub>y</sub> -AlN System", pp. 227-235, 1991, Journal of Non-Crystalline Solids, Vol. 135

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